



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 8, 2026	
IGI Report Number	LG825606700
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.37 - 9.44 X 5.55 MM

GRADING RESULTS

Carat Weight	3.00 CARATS
Color Grade	G
Clarity Grade	VS 1
Cut Grade	EXCELLENT

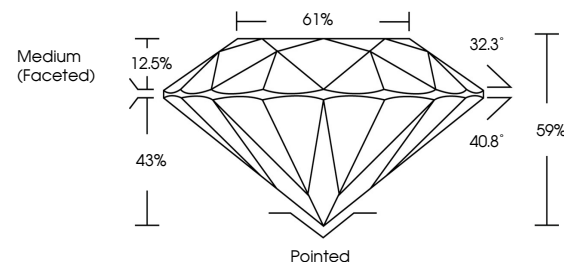
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG825606700

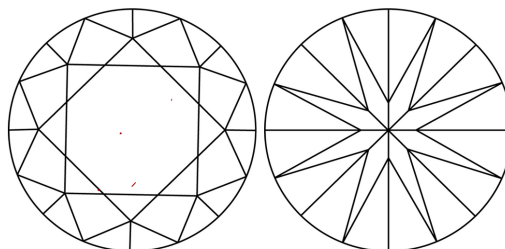
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG825606700
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

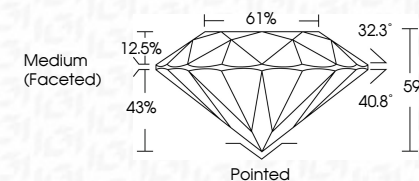
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ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG825506700
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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August 8, 2026
GI Report No. LG2650700
SOUND BRILLIANT
3.00 CARATS
VSI
EXCELLENT
99%
61%
Medium (Faceted)
Poished
EXCELLENT
EXCELLENT
NONE
(#) LG505606700
Comments:
Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIGa